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NO. 3356 P. 3/10

OCT 19 2005

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR HIGH-THROUGHPUT ION BEAM-ASSISTED
DEPOSITION (IBAD)

App. No.: 10/602,467

Filed: June 23, 2003

Examiner: Brain K. Talbot

Group Art Unit: 1762

Customer No.: 34456

Confirmation No.: 2664

Atty. Dkt. No.: 1014-SP103

MS AMENDMENT

Commissioner for Patents

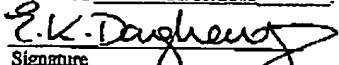
PO Box 1450

Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed July 19, 2005, please amend the above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on 10/19/2005	
Elise K. Dougherty	
Typed or Printed Name	Signature